



PATENT  
Customer No. 22,852  
Attorney Docket No. 7553.0008

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Chishio KOSHIMIZU et al. ) Group Art Unit: 1765  
Application No: 09/665,940 ) Examiner: L. UMEZ ERONINI  
Filed: September 21, 2000 )  
For: PLASMA PROCESSING )  
APPARATUS AND PLASMA )  
PROCESSING METHOD )

**Mail Stop RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**

Applicants hereby petition for a two month extension of time to reply to the Office Action of August 27, 2003 and Advisory Action of December 29, 2003. The additional required fee of \$310.00 for the second month extension is enclosed (\$110.00 having already been paid with the Petition for Extension of Time - One Month filed with the Amendment After Final dated December 4, 2003).

Please grant any extensions of time required to enter this response and charge any additional required fees to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: January 12, 2004

By: 

Michael W. Kim  
Reg. No. 51,880

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